

AUTHOR INDEX

-
- Armgarth, M., 91
 Belko, J. A., 161
 Bergveld, P., 11, 109, 129
 Bourke, P., 251
 Danielsson, B., 91
 Duszak, M., 245
 Evans, A. G. R., 219
 Firth, J. G., 281
 Fjeldly, T. A., 261
 French, P. J., 219
 Gangal, S. A., 149
 Gustafsson, K., 235
 Hager, H. E., 161
 Haskard, M. R., 3
 Heiland, G., 101, 227
 Hök, B., 235
 Hoogerwerf, A. C., 39
 Huang, P. H., 23
 Jadhav, M. L., 149
 Jakubowski, A., 245
 Janoska, I., 3
 Jones, T. A., 281
 Karekar, R. N., 149
 Kataoka, S., 29
 King, A. A., 49
 Kohl, D., 101, 227
 Kordić, S., 197
 Kostov, P. T., 307
 Leppävuori, S., 271
 Lundström, I., 91
 McAleer, J. F., 251
 Mann, B., 281
 Martin, S. J., 319
 Meijer, H. C., 187
 Middelhoek, S., 39
 Mlinar, J. W., 181
 Mokwa, W., 101
 Moseley, P. T., 251
 Nagy, K., 261
 Norris, J. O. W., 251
 Otagawa, T., 65
 Reinhoudt, D. N., 129
 Ricco, A. J., 319
 Romppainen, P., 271
 Roumenin, Ch. S., 307
 Sarro, P. M., 187
 Spetz, A., 91
 Stephan, R., 251
 Stetter, J. R., 65
 Sudhölter, E. J. R., 129
 Sugiyama, Y., 29
 Torvela, H., 271
 Väänänen, J., 271
 van der Berg, A., 129
 van der Jagt, P. C. M., 197
 van der Schoot, B., 11
 van Herwaarden, A. W., 187
 White, R. M., 49
 Winquist, F., 91
 Zaromb, S., 65
 Zipperian, T. E., 319

SUBJECT INDEX

- Acoustic wave
 - surface, gas sensor based on film conductivity changes, 319
- Aluminum
 - humidity-sensitive Al-nC-SiO_x-pSi-Al structures, 245
 - study of effect of humidity on AlO_x thin-film resistors, 149
- Ammonia
 - biosensors based on ammonia sensitive metal-oxide-semiconductor structures, 91
- Antimony
 - S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29
- Arsenic
 - S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29
- Arsine
 - an SnO₂ thin film for sensing, 101
- Biosensors
 - based on ammonia sensitive metal-oxide-semiconductor structures, 91
- Carbon
 - humidity-sensitive Al-C-SiO_x-pSi-Al structures, 245
- Carbon monoxide
 - detection by photoimpedance response of semiconductor film sensors, 161
 - effect of CH₄, SO₂ and NO on CO response of SnO₂-based thick film gas sensor in combustion gases, 271
- Cells
 - modular reaction, paper strips containing, 181
- Chemical sensor
 - actuator system, integration of; ISFET-based microlitre titrator, 11
- Chemical surface
 - modification, sensitivity control of ISFETs by, 129
- Combustion gases
 - effect of CH₄, SO₂ and NO on CO response of SnO₂-based thick film gas sensor in, 271
- Conductivity changes
 - surface acoustic wave gas sensor based on film, 319
- Differential potentiometric sensors
 - glass electrodes with solid-state membrane contacts and their application in, 261
- Electrical characterization
 - of water vapour/polymeric film system for humidity sensing, 23
- Electrical conductivity
 - of some metal oxides in inert and reducing atmospheres at high temperature, effect of oxygen on, 281
- Electrochemical sensor
 - and instrument for monitoring methane, room-temperature, 65
- Electrodes
 - glass, with solid-state membrane contacts and their application in differential potentiometric sensors, 261
- Electronic implantation
 - of sensitivity-variation offset-reduction method, theory and practice of, 197
- Gallium
 - S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29
- Glass electrodes
 - with solid-state membrane contacts and their application in differential potentiometric sensors, 261
- Gas sensor(s)
 - oxidic and organic semiconductor, problems and possibilities, 227
 - surface acoustic wave, based on film conductivity changes, 319
 - tin dioxide
 - SnO₂-based thick film, effect of CH₄, SO₂ and NO on CO response of, in combustion gases, 271

- use of Seebeck effect, 251
- Hall sensors
 - S/N study of micro-, made of single crystal InSb and GaAs, 29
- Humidity
 - study of effect of, on AlO_x thin-film resistors, 149
- Humidity sensing
 - water vapour/polymeric film system for, electrical and thermodynamic characterization of, 23
- Humidity-sensitive
 - Al-C-SiO_x-pSi-Al structures, 245
- Indium
 - S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29
- ISFET(s)
 - based microlitre titrator; integration of chemical sensor-actuator system, 11
 - sensitivity control of, by chemical surface modification, 129
- Magnetic field
 - functional multisensor for, and temperature measurements, 307
- Metal oxides
 - effect of oxygen on electrical conductivity of some, in inert and reducing atmospheres at high temperatures, 281
- Methane
 - effect of CH₄ on CO response of SnO₂-based thick film gas sensor in combustion gases, 271
 - room-temperature electrochemical sensor and instrument for monitoring, 65
- Micromechanical elements
 - vibration analysis of, 235
- Modular reaction cells
 - paper strips containing, 181
- MOSFET
 - based sensors, impact of, 109
- Multisensor
 - for magnetic field and temperature measurements, functional, 307
- Nitrous oxide
 - effect of NO on CO response of SnO₂-based thick film gas sensor in combustion gases, 271
- Offset-reduction method
 - sensitivity-variation, theory and practice of electronic implementation of, 197
- Optical image
 - tactile sensing array based on forming and detecting, 49
- Oxygen
 - effect of, on electrical conductivity of some metal oxides in inert and reducing atmospheres at high temperature, 281
- Photoimpedance response
 - CO detection by, of semiconductor film sensors, 161
- Polymeric film system
 - water vapour/, for humidity sensing, electrical and thermodynamic characterization of, 23
- Reaction cells
 - paper strips containing modular, 181
- Resistors
 - AlO_x thin-film, study of effect of humidity on, 149
- Seebeck effect
 - tin dioxide gas sensors, use of Seebeck effect, 251
- Semiconductor
 - biosensors based on ammonia sensitive metal-oxide-semiconductor structures, 91
 - film sensors, CO detection by photoimpedance of, 161
 - gas sensors, problems and possibilities of oxidic and organic, 227
- Sensitivity control
 - of ISFETs by chemical surface modification, 129
- Sensitivity-variation
 - offset-reduction method, theory and practice of electronic implementation of, 197
- Sensor(s)
 - differential potentiometric, glass electrodes with solid-state membrane contacts and their application in, 261
 - electrochemical, and instrument for monitoring methane, room-temperature, 65

- functional multisensor for magnetic field and temperature measurements, 307
- gas
 - oxidic and organic semiconductor, problems and possibilities of, 227
 - SnO_2 -based thick film, effect of CH_4 , SO_2 and NO on CO response of, in combustion gases, 271
 - surface acoustic wave, based on film conductivity changes, 319
 - tin dioxide; use of Seebeck effect, 251
- integrated vacuum, 187
- micro-Hall, made of single crystals
 - InSb and GaAs , S/N study of, 29
- MOSFET-based, impact of, 109
- polycrystalline silicon strain, 219
- semiconductor film, CO detection by photoimpedance response of, 161
- smart; when and where? 39
- Sensor-actuator system
 - chemical, integration of; ISFET-based microlitre titrator, 11
- Silicon
 - humidity-sensitive $\text{Al-C-SiO}_x\text{-pSi-Al}$ structures, 245
 - polycrystalline silicon strain sensors, 219
- Smart sensors
 - when and where? 39
- Strain sensors
 - polycrystalline silicon, 219
- Sulphur dioxide
 - effect of SO_2 on CO response of SnO_2 -based thick film gas sensor in combustion gases, 271
- Tactile sensing array
 - based on forming and detecting an optical image, 49
- Temperature measurements
 - functional multisensor for magnetic field and, 307
- Temperature sensor
 - thick film standard paste, applications, 3
- Thermodynamic characterization
 - of water vapour/polymeric film system for humidity sensing, 23
- Tin dioxide
 - effect of CH_4 , SO_2 and NO on CO response of SnO_2 -based thick-film gas sensor in combustion gases, 271
 - gas sensors; use of Seebeck effect, 251
 - an SnO_2 thin film for sensing arsine, 101
- Titration
 - ISFET-based microlitre; integration of chemical sensor-actuator system, 11
- Vacuum sensor
 - integrated, 187
- Vibration analysis
 - of micromechanical elements, 235
- Water vapour
 - /polymeric film system for humidity sensing, electrical and thermodynamic characterization of, 23

